#### Lumped-Element System Dynamics

#### **Joel Voldman\***

# Massachusetts Institute of Technology

#### \*(with thanks to SDS)

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# Outline

- > Our progress so far
- > Formulating state equations
- > Quasistatic analysis
- > Large-signal analysis
- > Small-signal analysis
- > Addendum: Review of 2<sup>nd</sup>-order system dynamics

- > Our goal has been to model multi-domain systems
- > We first learned to create lumped models for each domain
- > Then we figured out how to move energy between domains
- > Now we want to see how the multi-domain system behaves over time (or frequency)

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### Our progress so far...

#### > The Northeastern/ADI RF Switch

#### > We first lumped the mechanical domain

Images removed due to copyright restrictions.

Figure 11 on p. 342 in: Zavracky, P. M., N. E. McGruer, R. H. Morrison, and D. Potter. "Microswitches and Microrelays with a View Toward Microwave Applications." International Journal of RF and Microwave Comput-Aided Engineering 9, no. 4 (1999): 338-347.



Image by MIT OpenCourseWare.

Adapted from Rebeiz, Gabriel M. *RF MEMS: Theory, Design, and Technology*. Hoboken, NJ: John Wiley, 2003. ISBN: 9780471201694.



Image by MIT OpenCourseWare. Adapted from Figure 6.9 in Senturia, Stephen D. *Microsystem Design*. Boston, MA: Kluwer Academic Publishers, 2001, p. 138. ISBN: 9780792372462.

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### Our progress so far...

- > Then we introduced a two-port capacitor to convert energy between domains
  - Capacitor because it stores potential energy
  - Two ports because there are two ways to store energy
    - » Mechanical: Move plates (with charge on plates)
    - » Electrical: Add charge (with plates apart)
  - The system is conservative: system energy only depends on state variables



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### Our progress so far...

- > We first analyzed system quasistatically
- Saw that there is VERY different behavior depending on whether
  - Charge is controlled
  - ➔ stable behavior at all gaps
  - Voltage is controlled
  - $\rightarrow$  pull-in at g=2/3g<sub>0</sub>
- > Use of energy or co-energy depends on what is controlled
  - Simplifies math

$$F = \frac{\partial W(Q,g)}{\partial g}\Big|_{Q} = \frac{Q^{2}}{2\varepsilon A}$$

$$V = \frac{\partial W(Q,g)}{\partial Q}\Big|_{g} = \frac{Qg}{\varepsilon A}$$

$$dW = VdQ + Fdg$$

$$dW^{*} = QdV - Fdg$$

$$Q = \frac{\partial W^{*}}{\partial V}\Big|_{g} = \frac{\varepsilon A}{g}V_{in}$$

$$F = \frac{\partial W^{*}}{\partial g}\Big|_{V} = \frac{\varepsilon A V_{in}^{2}}{2g^{2}}$$

# Today's goal

- > How to move from quasi-static to dynamic analysis
- > Specific questions:
  - How fast will RF switch close?
- > General questions:
  - How do we model the dynamics of non-linear systems?
  - How are mechanical dynamics affected by electrical domain?
- > What are the different ways to get from model to answer?

# Outline

- > Our progress so far
- > Formulating state equations
- > Quasistatic analysis
- > Large-signal analysis
- > Small-signal analysis
- > Addendum: Review of 2<sup>nd</sup>-order system dynamics

# **Adding dynamics**

- > Add components to complete the system:
  - Source resistor for the voltage source
  - Inertial mass, dashpot
- > This is now our RF switch!
- > System is nonlinear, so we can't use Laplace to get transfer functions
- Instead, model with state equations



Image by MIT OpenCourseWare.

Adapted from Figure 6.9 in Senturia, Stephen D. *Microsystem Design*. Boston, MA: Kluwer Academic Publishers, 2001, p. 138. ISBN: 9780792372462.

**Electrical domain** 

Mechanical domain

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# **State Equations**

- > Dynamic equations for general system (linear or nonlinear) can be formulated by solving equivalent circuit
- In general, there is one state variable for each independent energy-storage element (port)
- > Good choices for state variables: the charge on a capacitor (displacement) and the current in an inductor (momentum)
- > For electrostatic transducer, need three state variables
  - Two for transducer (Q,g)
  - One for mass (dg/dt)





#### **Formulating state equations**

- > Start with *Q*
- > We know that *dQ/dt=I*
- > Find relation between I and state variables and constants

$$KVL: V_{in} - e_R - V = 0$$

$$e_R = IR$$

$$V_{in} - IR - V = 0$$

$$\frac{dQ}{dt} = I = \frac{1}{R} (V_{in} - V)$$

$$V = \frac{Qg}{\varepsilon A}$$

$$\frac{dQ}{dt} = \frac{1}{R} \left( V_{in} - \frac{Qg}{\varepsilon A} \right)$$







#### **Formulating state equations**



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### **Formulating state equations**

- > State equation for g is easy:
- $\frac{dg}{dt} = \dot{g}$

> Collect all three nonlinear state equations

$$\frac{d}{dt}\begin{bmatrix} Q\\g\\\dot{g}\\\dot{g}\end{bmatrix} = \begin{bmatrix} \frac{1}{R}\left(V_{in} - \frac{Qg}{\varepsilon A}\right)\\ \dot{g}\\ -\frac{1}{m}\left[\frac{Q^2}{2\varepsilon A} - k(g_0 - g) + b\dot{g}\right] \end{bmatrix}$$

#### > Now we are ready to simulate dynamics

# Outline

- > Our progress so far
- > Formulating state equations
- > Quasistatic analysis
- > Large-signal analysis
- > Small-signal analysis
- > Addendum: Review of 2<sup>nd</sup>-order system dynamics

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### **Quasistatic analysis**



#### Equivalent circuit

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### **State equations**



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# **Fixed points**

- > Definition of a fixed point
  - Solution of f(x,u) = 0
  - time derivatives  $\rightarrow$  0

#### > Global fixed point

- A fixed point when u = 0
- Systems can have multiple global fixed points
- Some might be stable, others unstable (consider a pendulum)

#### > Operating point

Fixed point when u is a non-zero constant

#### Fixed points of the electrostatic actuator

> This analysis is analogous to what we did last time...



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# Outline

- > Our progress so far
- > Formulating state equations
- > Quasistatic analysis
- > Large-signal analysis
- > Small-signal analysis
- > Addendum: Review of 2<sup>nd</sup>-order system dynamics

#### Large-signal analysis



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

- > This is a brute force approach: integrate the state equations
  - Via MATLAB<sup>®</sup> (ODExx)
  - Via Simulink<sup>®</sup>

#### > We show the SIMULINK<sup>®</sup> version here

Matlab<sup>®</sup> version later

#### **Electrostatic actuator in Simulink®**





Image by MIT OpenCourseWare.

Adapted from Figure 7.8 in Senturia, Stephen D. *Microsystem Design*. Boston, MA: Kluwer Academic Publishers, 2001, p. 174. ISBN: 9780792372462.

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### **Electrostatic actuator with contact**



Image by MIT OpenCourseWare.

Adapted from Figure 7.9 in Senturia, Stephen D. *Microsystem Design*. Boston, MA: Kluwer Academic Publishers, 2001, p. 175. ISBN: 9780792372462.

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### **Behavior through pull-in**



Image by MIT OpenCourseWare.

Adapted from Figure 7.10 in Senturia, Stephen D. *Microsystem Design*. Boston, MA: Kluwer Academic Publishers, 2001, p. 176. ISBN: 9780792372462.

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### **Behavior through pull-in**



Image by MIT OpenCourseWare.

Adapted from Figure 7.11 in Senturia, Stephen D. Microsystem Design. Boston, MA: Kluwer Academic Publishers, 2001, p. 177. ISBN: 9780792372462.

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# Outline

- > Our progress so far
- > Formulating state equations
- > Quasistatic analysis
- > Large-signal analysis
- > Small-signal analysis
- > Addendum: Review of 2<sup>nd</sup>-order system dynamics

### **Small-signal analysis**



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

### **Small-signal analysis**



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# Linearization about a fixed point

#### > This is EXTREMELY common in MEMS literature

- > This is also done in many other fields, with different names
  - Small-signal analysis
  - Incremental analysis
  - Etc.

# **Linearization About an Operating Point**

> Using Taylor's theorem, a system can  $\dot{\mathbf{x}} = f(\mathbf{x}, \mathbf{u})$ be linearized about any fixed point We can do this in one dimension or **Operating point** many  $\dot{\mathbf{X}}_{\mathbf{0}} + \frac{d(\delta \mathbf{x})}{dt} = f(\mathbf{X}_{\mathbf{0}} + \delta \mathbf{x}, \mathbf{U}_{\mathbf{0}} + \delta \mathbf{u})$ Multi-dimensional Taylor f(x)df/dx  $f(X_0 + \delta x) = f(X_0) = Y_0$  $\dot{\mathbf{X}}_{\mathbf{0}} + \frac{d(\partial \mathbf{x})}{dt} = f(\mathbf{X}_{\mathbf{0}}, \mathbf{U}_{\mathbf{0}}) + \left(\frac{\partial f_i}{\partial x_j}\Big|_{\mathbf{x} \in U}\right) \partial \mathbf{x}(t) + \left(\frac{\partial f_i}{\partial u_j}\Big|_{\mathbf{x} \in U_0}\right) \partial \mathbf{u}(t)$  $-\delta x$ Cancel  $\frac{d(\delta x_i(t))}{dt} = \left(\frac{\partial f_i}{\partial x_j}\Big|_{X_0, U_0}\right) \delta x_i(t) + \left(\frac{\partial f_i}{\partial u_j}\Big|_{X_0, U_0}\right) \delta u_i(t)$  $X_{o}$  $f(X_0 + \delta x) \approx f(X_0) + \frac{df}{dx}\Big|_{v} \delta x$ 

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# **Linearization About an Operating Point**

- The resulting set of equations are linear, and have dynamics described by the Jacobians of f(x,u) evaluted at the fixed point.
- > These describe how much a small change in one state variable affects itself or another state variable
- > The O.P. must be evaluated to use the Jacobian
- > Example linearization of the voltage-controlled electrostatic actuator

$$\partial \dot{\mathbf{x}}(\mathbf{t}) = \mathbf{J}_1 \partial \mathbf{x} + \mathbf{J}_2 \partial \mathbf{u}(\mathbf{t})$$



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# **State Equations for Linear Systems**

> Normally expressed with:

- x: a vector of state variables
- u: a vector of inputs
- y: a vector of outputs
- Four matrices, A,B,C, D

 $\dot{\mathbf{x}} = \mathbf{A}\mathbf{x} + \mathbf{B}\mathbf{u}$ 

$$\mathbf{y} = \mathbf{C}\mathbf{x} + \mathbf{D}\mathbf{u}$$

> For us, Jacobian matrices take the place of A and B

> C and D depend on what outputs are desired

- Often C is identity and D is zero
- > Can use to simulate time responses to arbitrary <u>SMALL</u> inputs
  - Remember, this is only valid for small deviations from O.P.

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# **Direct Integration in Time**

Impulse Response 1000 > Can integrate via Simulink<sup>®</sup> model (as before) or Charge 500 MATI AB® > First define system in MATI AB® using ss(J1, J2, C, D) or Displacement alternate method > Can use MATLAB<sup>®</sup> commands step, initial, impulse etc. 2 > Response of electrostatic Velocity  $\left( \right)$ actuator to impulse of voltage Parameters from text (pg 167) -6 5 15 20 25 Time (sec)

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

### **Small-signal analysis**



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# Solve via Laplace transform

# > Use Laplace Transforms

to solve in frequency domain

- Transform DE to algebraic equations
- Use unilateral Laplace to allow for non-zero IC's

- > Transfer functions H(s) are useful for obtaining compact expression of input-output relation
  - What is the tip displacement as a function of voltage
- > Most easily obtained from equivalent circuit
- > But can also be obtained from linearized state eqns
  - Depends on A, B, C (or J<sub>1</sub>, J<sub>2</sub>, C) matrices
  - Can do this for fun analytically (see attachment at end)
  - Matlab can automatically convert from s.s to t.f. formulations
- > For our actuator, we would get three transfer functions



# **Sinusoidal Steady State**

- > When a LTI system is driven with a sinusoid, the steady-state response is a sinusoid at the same frequency
- > The amplitude of the response is |H(jω)|
- The phase of the response relative to the drive is the angle of H(jω)
- > A plot of log magnitude vs log frequency and angle vs log frequency is called a Bode plot

$$u(t) = U_0 \cos(\omega t)$$

$$V(j\omega) = H(j\omega)U(j\omega)$$

$$y_{sss}(t) = Y_0 \cos(\omega t + \theta)$$

$$Y_0 = |H(j\omega)|U_0$$
  
$$\tan\theta = \frac{\operatorname{Im}\{H(j\omega)\}}{\operatorname{Re}\{H(j\omega)\}}$$

### Bode plot of electrostatic actuator



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

### **Small-signal analysis**



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### **Poles and Zeros**

- > For our models, system function is a ratio of polynomials in s
- > Roots of denominator are called poles
  - They describe the natural (unforced) response of the system
- > Roots of the numerator are called zeros
  - They describe particular frequencies that fail to excite any output
- > System functions with the same poles and zeros have the same dynamics

$$\mathbf{H}(s) = \frac{\mathbf{g}(s)}{\mathbf{V}_{in}(s)} = \frac{\frac{-Q_0}{\varepsilon ARm}}{s^3 + \left(\frac{1}{RC_0} + \frac{b}{m}\right)s^2 + \left(\frac{1}{RC_0}\frac{b}{m} + \frac{k}{m}\right)s + \left(\frac{1}{RC_0}\frac{k}{m} - \frac{Q_0^2}{\varepsilon^2 A^2}\frac{1}{Rm}\right)}$$
where  $C_0 = \frac{\varepsilon A}{\hat{g}_0}$ 

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# Pole-zero diagram

- > Displays information about dynamics of system function
  - Matlab command pzmap
- > Useful for examining dynamics, stability, etc.



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

## **Small-signal analysis**



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# **Eigenfunction Analysis**

For an LTI system, we can find the eigenvalues and eigenvectors of the J<sub>1</sub> (or A) matrix describing the internal dynamics

For scalar 1<sup>st</sup>-order system:

 $\frac{dx}{dt} = \lambda x \quad \Rightarrow x(t) = K_0 e^{\lambda t} + K_1$ 

Our linear (or linearized) homogeneous systems look like:

$$\delta \dot{\mathbf{x}}(\mathbf{t}) = \mathbf{J}_1 \delta \mathbf{x} + \mathbf{J}_2 \delta \mathbf{u}(\mathbf{t})$$
$$\frac{d\mathbf{x}}{dt} = \mathbf{A} \mathbf{x} \qquad \qquad \frac{d(\delta \mathbf{x})}{dt} = \mathbf{J}_1 \delta \mathbf{x}$$

If we try solution:  $\mathbf{X}(t) = \mathbf{K}e^{\lambda t}$ Plug into DE:  $\lambda \mathbf{X} = \mathbf{A}\mathbf{X}$ •This is an eigenve

This is an eigenvalue equation
If we find λ we can find natural frequencies of system

# **Eigenfunction Analysis**

- > These  $\lambda$  are the same as the poles  $s_i$  of the system
- > Can solve analytically
  - Find  $\lambda$  from det(A- $\lambda$ I)=0
- > Or numerically eig(sys)

-8.9904

-0.2627 + 0.8455i

-0.2627 - 0.8455i

## Linearized system poles

- We can use either λ<sub>i</sub> or s<sub>i</sub> to determine natural frequencies of system
- > As we increase applied voltage
  - Stable damped resonant frequency decreases
- > Plotting poles as system changes is a root-locus plot



# **Spring softening**

- > Plot damped resonant frequency versus applied voltage
- > Resonant frequency is changing because net spring constant k changes with frequency
- > This is an electrically tuned mechanical resonator



Adapted from Figure 7.5 in Senturia, Stephen D. *Microsystem Design*. Boston, MA: Kluwer Academic Publishers, 2001, p. 169. ISBN: 9780792372462.

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

## **Small-signal analysis**



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

- > Can we directly linearize our equivalent circuit? YES!
- > This is perhaps the most common analysis in the literature
- > First, choose what is load and what is transducer
  - Here we include spring with transducer



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# **Linearized Transducer Model**

> First, find O.P.

 $V_0, \, \hat{g}_0, \, Q_0$ 

- Next, generate matrix to relate *incremental* port variables to each other
  - Start from energy and force relations

$$V = \frac{Qg}{\varepsilon A}$$
$$F_{out} = \frac{Q^2}{2\varepsilon A} - k(g_0 - g)$$

Linearize (take partials...)

$$\begin{bmatrix} \delta V \\ \delta F_{out} \end{bmatrix} = \begin{bmatrix} \frac{\hat{g}_0}{\varepsilon A} & \frac{Q_0}{\varepsilon A} \\ \frac{Q_0}{\varepsilon A} & k \end{bmatrix} \begin{bmatrix} \delta Q \\ \delta g \end{bmatrix}$$

> Recast in terms of port variables

$$\begin{bmatrix} \delta Q \\ \delta g \end{bmatrix} = \begin{bmatrix} \delta I / s \\ \delta U / s \end{bmatrix}$$

> Define intermediate variables

$$C_0 = \frac{\varepsilon A}{\hat{g}_0}, \ V_0 = \frac{Q_0}{C_0}$$

> Final expression



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

- > Now we want to convert this relation into a circuit
- Many circuit topologies are consistent with this matrix relation
   THIS IS NOT UNIQUE!



Adapted from Figure 5 on p. 163 in Tilmans, Harrie A. C. "Equivalent Circuit Representations of Electromechanical Transducers: I. Lumped-parameter Systems." *Journal of Micromechanics and Microengineering* 6, no. 1 (1996): 157-176.

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

δΙ

+

 $\delta V$ 

> This is the one used in the text

$$\begin{bmatrix} \delta V \\ \delta F_{out} \end{bmatrix} = \begin{bmatrix} Z_{EB} & \varphi Z_{EB} \\ \varphi Z_{EB} & Z_{MO} \end{bmatrix} \begin{bmatrix} \delta I \\ \delta U \end{bmatrix}$$
$$Z_{MS} = Z_{MO} \left( 1 - \frac{\varphi^2 Z_{EB}}{Z_{MO}} \right)$$

- > Uses a transformer
  - Transforms port variables
  - Doesn't store energy
- What we want to do now is identify Z<sub>EB</sub>, Z<sub>MS</sub> and φ, and figure out what they mean...





Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

- > C<sub>0</sub> represents the capacitance of the structure seen from the electrical port
- It is simply the capacitance at the gap given by the operating point
- > As V<sub>in</sub> increases, C<sub>0</sub> will increase until the structure pulls in

#### > This is a tunable capacitor

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].





 $C_0 = \frac{\varepsilon A}{\hat{g}_0}$ 

- > k' represents the effective
  spring
- > A combination of the mechanical spring k and the electrical spring
- > This is an electrically tunable spring!
  - Spring softening shows up in k'
- > As V<sub>in</sub> increases, k' will decrease from k (at V<sub>in</sub>=0) to 0 (at V<sub>in</sub>=V<sub>pi</sub>)





- \$\varphi\$ represents the electromechanical coupling
- > Represents how much the capacitance changes with gap
- > A measure of sensitivity

$$\begin{split} \varphi &= -V_0 \frac{\partial C}{\partial g} \Big|_{O.P.} = -V_0 \frac{\partial}{\partial g} \frac{\mathcal{E}A}{g} \Big|_{O.P.} \\ &= V_0 \frac{\mathcal{E}A}{\hat{g}_0^2} \\ &= \frac{C_0 V_0}{\hat{g}_0} \end{split}$$







> Can use linearized circuit to construct H(s) using complex impedances



- > Usually helpful to "eliminate" transformer
- > Transformer changes impedances





Can now get any transfer function using standard circuit analysis

# **Linearized Transducer Models**

#### > Now we can understand Nguyen's filter!

Image removed due to copyright restrictions. Figure 9 on p. 17 in Nguyen, C. T.-C. "Vibrating RF MEMS Overview: Applications to Wireless Communications." *Proceedings of SPIE Int Soc Opt Eng* 5715 (January 2005): 11-25. Image removed due to copyright restrictions. Figure 12 on p. 62 in: Nguyen, C. T.-C. "Micromechanical Filters for Miniaturized Low-power Communications." *Proceedings of SPIE Int Soc Opt Eng* 3673 (July 1999): 55-66.

#### **Small-signal analysis summary**



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

- > We can now analyze and design both quasistatic and dynamic behavior of our multi-domain MEMS
- > We have much more powerful tools to analyze linear systems than nonlinear systems
- > But most systems we encounter are nonlinear
- > Linearization permits the study of small-signal inputs
- > Next up: special topics in structures, heat transfer, fluids

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### Review: analysis of a 2<sup>nd</sup>-order linear system

> Spring-mass-dashpot





Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### **Direct Integration in Time**

- > Example: Spring-mass-dashpot step response
  - *k=m=*1;*b*=0.5;



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### > Can get TFs from A,B,C matrices

$$\mathbf{Y}(s) = \mathbf{C}\mathbf{X}(s) + \mathbf{D}\mathbf{U}(s)$$
  

$$\mathbf{Y}(s) = \mathbf{C}\left[(s\mathbf{I} - \mathbf{A})^{-1}\mathbf{X}(0) + (s\mathbf{I} - \mathbf{A})^{-1}\mathbf{B}\mathbf{U}(s)\right] + \mathbf{D}\mathbf{U}(s)$$
  
Assume transient has died out (X<sub>ZIR</sub>=0)  
No feed-through (D=0)  

$$\mathbf{Y}(s) = \left[\mathbf{C}(s\mathbf{I} - \mathbf{A})^{-1}\mathbf{B}\right]\mathbf{U}(s)$$
  

$$\mathbf{Y}(s) = \mathbf{H}(s)\mathbf{U}(s)$$

$$\mathbf{H}(s) = \left[\mathbf{C}\left(s\mathbf{I} - \mathbf{A}\right)^{-1}\mathbf{B}\right]$$

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

Let's do analytically & via MATLAB	$\begin{bmatrix} X(s) \end{bmatrix} \begin{bmatrix} 1 \end{bmatrix}$
$s\mathbf{I} - \mathbf{A} = \begin{bmatrix} s & 0 \\ 0 & s \end{bmatrix} - \begin{bmatrix} 0 & 1 \\ -\frac{k}{m} & -\frac{b}{m} \end{bmatrix}$	$\mathbf{H}(s) = \begin{vmatrix} \overline{\mathbf{F}(s)} \\ \underline{\dot{\mathbf{X}}(s)} \\ \hline \\ \frac{\dot{\mathbf{X}}(s)}{2} \end{vmatrix} = \begin{vmatrix} \frac{1}{ms^2 + sb + k} \\ \frac{s}{2} \end{vmatrix}$
$= \begin{bmatrix} s & -1 \\ k \not m & s + b \not m \end{bmatrix}$	$\begin{bmatrix} F(s) \end{bmatrix} \begin{bmatrix} ms^2 + sb + k \end{bmatrix}$ $\begin{bmatrix} \frac{1}{2} & 0 & 5 \end{bmatrix}$
$(s\mathbf{I} - \mathbf{A})^{-1} = \frac{1}{\Delta} \begin{bmatrix} s + b/m & 1\\ -k/m & s \end{bmatrix}$	$\mathbf{H}(s) = \begin{bmatrix} s^2 + 0.5s + 1 \\ \frac{s}{s^2 + 0.5s + 1} \end{bmatrix}$
$\Delta = s(s+b/m) + k/m = s^2 + sb/m + k/m$	>> [n,d]=ss2tf(A,B,C,D)
$\mathbf{C}(s\mathbf{I}-\mathbf{A})^{-1}\mathbf{B} = \begin{bmatrix} 1 & 0 \\ 0 & 1 \end{bmatrix} \frac{1}{\Delta} \begin{bmatrix} s+b/m & 1 \\ -k/m & s \end{bmatrix} \begin{bmatrix} 0 \\ 1/m \end{bmatrix}$	$n = \begin{array}{cccc} \mathbf{s}^2 & \mathbf{s}^1 & \mathbf{s}^0 \\ 0 & -0.0000 & 1.0000 \\ 0 & 1.0000 & -0.0000 \end{array}$
$=\frac{1}{\Delta}\begin{bmatrix}1/m\\s\\s/m\end{bmatrix}$	d = 1.0000 0.5000 1.0000

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

> Can also construct H(s) directly using complex impedances and circuit model





Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### **Poles and Zeros**

For 2<sup>nd</sup>-order system, easy to get poles and zeros from TFs

$$\mathbf{H}(s) = \frac{1}{m} \begin{bmatrix} \frac{1}{s^2 + s b/m + k/m} \\ \frac{s}{s^2 + s b/m + k/m} \end{bmatrix}$$
$$= \frac{1}{m} \begin{bmatrix} \frac{1}{(s - s_1)(s - s_2)} \\ \frac{s}{(s - s_1)(s - s_2)} \end{bmatrix}$$

where

$$\mathbf{s}_{1,2} = -\frac{b}{2m} \pm \sqrt{\left(\frac{b}{2m}\right)^2 - \frac{k}{m}}$$

these are the poles

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

# Spring-mass-dashpot system

- It is a second order system, with two poles
- > We conventionally define
  - Undamped resonant frequency
  - Damping constant
  - Damped resonant frequency
  - Quality factor

 $s^{2} + \frac{b}{m}s + \frac{k}{m} = s^{2} + 2\alpha s + \omega_{0}^{2}$ 

 $\omega_0 = \sqrt{\frac{k}{2}}$ 

$$s_{1,2} = -\alpha \pm \sqrt{\alpha^2 - \omega_0^2}$$

For underdamped systems ( $\alpha < \omega_0$ )

 $s_{1,2} = -\alpha \pm j\omega_{\rm d}$ 

where

$$\omega_{\rm d} = \sqrt{\omega_0^{2-}\alpha^2}$$

Quality factor :

 $Q = \frac{\omega_0}{2\alpha} = \frac{m\omega_0}{b}$ 

Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

> Displays information about dynamics of system function



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### **SMD-position frequency response**



Cite as: Joel Voldman, course materials for 6.777J / 2.372J Design and Fabrication of Microelectromechanical Devices, Spring 2007. MIT OpenCourseWare (http://ocw.mit.edu/), Massachusetts Institute of Technology. Downloaded on [DD Month YYYY].

#### **Eigenfunction Analysis**

> Find eigenvalues numerically using MATLAB and A matrix

$$\mathbf{A} = \begin{bmatrix} 0 & 1 \\ 0 & -0.5 \end{bmatrix}$$
$$[\mathbf{V}, \Lambda] = \operatorname{eig}(\mathbf{A})$$
$$\Lambda = \begin{bmatrix} \lambda_1 & 0 \\ 0 & \lambda_2 \end{bmatrix} = \begin{bmatrix} -0.25 + 0.97 \, j & 0 \\ 0 & -0.25 - 0.97 \, j \end{bmatrix}$$
$$\mathbf{V} = \begin{bmatrix} v_1 & v_2 \end{bmatrix} = \begin{bmatrix} 0.707 & 0.707 \\ -0.18 - 0.68 \, j & -0.18 - 0.68 \, j \end{bmatrix}$$